IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Patent Examiner: Chacko Davis, Daborah

Howard Ge, et al.

Group Art Unit: 1756

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Confirmation No.: 6075

Serial No.: 10/680,960 Filed: October 7, 2003

Title: PHOTORESIST COATING PROCESS

FOR MICROLITHOGRAPHY

August 31, 2007

Costa Mesa, California 92626

RESPONSE TO OFFICE ACTION

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Responsive to the Office Action of June 1, 2007, kindly amend the aboveidentified application as follows: